



**PATENT APPLICATION**

*JPW*  
*[Signature]*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masashi KITABAYASHI et al.

Group Art Unit: 2877

Application No.: 10/812,095

Examiner: A. H. Merlino

Filed: March 30, 2004

Docket No.: 110859.01

For: LENS EVALUATION METHOD AND LENS-EVALUATING APPARATUS

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 10, 2005 Office Action, and in conjunction with the attached  
Terminal Disclaimer, please consider the following:

**Amendments to the Specification; and**

**Remarks.**